



1762  
1FW

Attorney Docket SEL 238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of )  
Hiroki et al. )  
Serial No.: 09/776,472 )  
Filed: February 2, 2001 )  
For: Thin Film Formation Apparatus And )  
Method Of Manufacturing Self-Light- )  
Emitting Device Using Thin Film )  
Formation Apparatus )  
Art Unit: 1762 )  
Examiner: M. Cleveland )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Cristine M. Noll

Name of applicant, assignee, or Registered Rep.

Cristine M. Noll

1/17/2006

Signature

Date

**AMENDMENT H**

Sir:

In response to the Office Action of October 17, 2005, please amend the above-identified application as follows: